

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: P. Hassanz	zadah	
Kenichi KOTOKU	;	Examilier, P. massaiiz	aden	
Remem ROTORO	;	Group Art Unit: 1763	•	
Application No.: 09/960,694)		*.	
Filed: September 24, 2001	:) :	February 13, 2003	REC FEB TC 1700	
For: EXPOSURE APPARATUS AND)		00 田 円 円	
SEMICONDUCTOR DEVICE	•		A G	
MANUFACTURING METHOD)	:	RECEIVED FEB 19 2003 700 MAIL RO	
Commissioner for Patents Washington, D.C. 20231			ED 103 ROOM	
Sir:				
Transmitted herewith is a Response to Restriction	n Requiremen	t in the above-identified	application.	

X No additional fee is required.

The fee has been calculated as shown below:

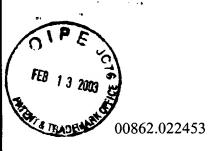
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	16	MINUS	20	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	4	MINUS	4	= 0	x \$42 \$84	\$0.00
Fee for Multiple Dependent claims \$140/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00	

[°]Verified Statement claiming small entity status is enclosed, if not filed previously.

Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed. X Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any aunder 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this prenclosed. A check in the amount of \$ to cover the fee for a month extension in A check in the amount of \$ to cover the Information Disclosure Statement fee is Applicant's undersigned attorney may be reached in our Washington, D.C. office by (202) 530-1010. All correspondence should be directed to our address given below. Respectfully submitted, Attorney for Applicant Steven E. Warner	
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(202) 530-1010. All correspondence should be directed to our address given below. Respectfully submitted, Attorney for Applicant	enclosed.
Attorney for Applicant	telephone at
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Registration No. 33,326	

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PATENT APPLICATION

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Washington, D.C. 20231			
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Sir:

Applicant respectfully traverses the restriction requirement set forth in the Office Action dated January 13, 2003.

In the Office Action, the Examiner sets forth a restriction requirement among four groups of claims. Group I, claims 1-12, is drawn to an exposure apparatus, and is classified in class 156, subclass 345.5; Group II, claim 13 (and presumably, claim 14), is drawn to a method of installing a plurality of semiconductor manufacturing apparatus including an exposure apparatus, and is classified in class 438, subclass 689; Group III, claim 15, is drawn to an apparatus including a local area network and a gateway, and is

classified in class 118, subclass 719; and Group IV, claim 16, is drawn to a method of maintaining an exposure apparatus including preparing a database, and is classified in class 438, subclass 708.

The Examiner contends that the inventions of Groups I-IV are variously related as process and apparatus for its practice or as subcombinations disclosed as usable together in a single combination, and have acquired a separate status in the art as shown by their different classification such that the searches are not coextensive, requiring separate examination. These contentions are respectfully traversed.

Applicant notes that the inventions of Groups I -IV are so closely related in the field of semiconductor manufacture, using an exposure apparatus, that a proper search of any of the claims would, of necessity, require a search of the others. Thus, it is submitted that all of the claims can be searched simultaneously, and that a duplicative search, with possibly inconsistent results, may occur if the restriction requirement is maintained.

Applicant further submits that any nominal burden placed upon the Examiner to search an additional subclass or two, necessary to determine the art relevant to Applicant's overall invention, is significantly outweighed by the public interest in not having to obtain and study several separate patents in order to have available all of the issued patent claims covering Applicant's invention. The alternative is to proceed with the filing of multiple applications, each consisting of generally the same disclosure, and each being subjected to essentially the same search, perhaps by different Examiners on different occasions. This places an unnecessary burden on both the Patent and Trademark Office and on Applicant.

In the interest of economy, for the Office, for the public-at-large and for Applicant, reconsideration and withdrawal of the restriction requirement are requested.

Nevertheless, in order to comply with the requirements of 37 CFR 1.143, Applicant provisionally elects, with traverse, to prosecute the invention of Group I, namely claims 1-12.

Favorable consideration and an early passage to issue are requested.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

Attorney for Applicant

Steven E. Warner

Registration No. 33,326

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